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REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:	10/604,116	Conf. No.:	1115
Filing Date:	06/26/2003	Art Unit:	2823
Applicant:	Anderson et al.	Examiner:	Garcia, Joannie A.
Title:	METHOD OF FORMING FREESTANDING SEMICONDUCTOR LAYER	Docket No.:	BUR920030031US1 (IBMB-0028)

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 571-273-8300


Transmitted herewith is: **After Final Request for Reconsideration
in 11 pages**

in the above identified application.

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Anderson *et al.* **Conf. No.:** 1115
Serial No.: 10/604,116 **Art Unit:** 2823
Filed: 06/26/2003 **Docket No.:** BUR920030031US1 (IBMB-0028)
Examiner: Joannie A. Garcia

Title: METHOD OF FORMING
FREESTANDING SEMICONDUCTOR
LAYER

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AFTER FINAL REQUEST FOR RECONSIDERATION

Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action of February 16, 2006, please re-consider the rejections based on the following remarks.